



501.41125X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. HIROI, et al
Serial No.: 10/062,666
Filed: February 5, 2002
For: PATTERN INSPECTION METHOD AND
SYSTEM THEREFOR
Group: 2881
Examiner: J. Berman

SUPPLEMENTAL AMENDMENT AFTER FINAL REJECTION

Mail Stop: Box AF Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 12, 2007

Sir:

The following supplemental amendments and remarks are respectfully submitted in connection with the above-identified application in response to the Office Action dated September 18, 2006, the Advisory Action dated January 30, 2007, and the telephone discussion with the Examiner. The amendments submitted are as listed below and as set forth on the following pages:

Amendment of the Claims; and

Remarks are included following the amendments.